REPORT DOCUMENTATION PAGE

Form Approved OMB NO. 0704-0188

Public Reporting burden for this collection	of information is e	stimated to average 1 hour p	per response, including the	time for reviewing inst	ructions, searching existing data sources,			
gautering and manitalining the data needed.	, and completing an	d reviewing the collection of	f information Send comp	ent regarding this burd	en estimates or any other aspect of this collection and Reports, 1215 Jefferson Davis Highway,			
Suite 1204, Armigion, VA 22202-4302, an	nd to the Office of M	Management and Budget, Pa	perwork Reduction Projec	t (0704-0188,) Washing	ton, DC 20503.			
1. AGENCY USE ONLY (Leave B	lank)	REPORT DATE	-		PE AND DATES COVERED			
		12/31/99			5/SEP/96 to 14/SEP/99			
4. TITLE AND SUBTITLE				6 FUNDING M	D. CDUTTO			
Core-Level Photoemission	Spectroscopy	5. FUNDING NU	MBERS					
Interfaces	,	DAAH04-9	6-1-0425					
					· · · · · · · · · · · · · · · · · · ·			
6. AUTHOR(S)								
J.E. Rowe and T.E. Madey								
,								
7. PERFORMING ORGANIZATION	N NAME(S) AN	8. PERFORMING	ORGANIZATION					
Rutgers University		REPORT NUMBER						
Physics Department								
Piscataway, NJ 08854-8010								
				a a				
9. SPONSORING / MONITORING	AGENCY NAM	10. SPONSORING	7 / MONITORING					
*** 6				AGENCY RE	PORT NUMBER			
U. S. Army Research Of	fice							
P.O. Box 12211		ARO 36165	i.3-PH-SR					
Research Triangle Park,	NC 27709-2							
11 CURRICULARY NOTES								
11. SUPPLEMENTARY NOTES	- findings							
Department of the Army positi	ion maliar or	danied in this report	t are those of the a	uthor(s) and shou	uld not be construed as an official			
Department of the Army positi	on, policy of	decision, unless so	designated by other	r documentation.	•			
12 a. DISTRIBUTION / AVAILABI	LITY STATEMI	ENT		12 b. DISTRIBUT	TON CODE			
				iz o. Distrabol	ION CODE			
Approved for public release	e; distribution	unlimited.						
13. ABSTRACT (Maximum 200 word	da)							
,		/ In als Days I						
to study inerfaces and surfaces	of electronic	(Jack Rowe's group,	in collaboration w	th Ted Madey) is	to use core level photoemission			
to study inerfaces and surfaces Spherical Grating Monochromat	tor (SGM) whi	ch is being performe	ic systems. I nere	is also an effort to	o upgrade this beamline to a			
asca in current devices have co	munuea to aet	crease in inickness i	NITH COTTES MANAGINA	improvements in	oxido anovala anasassis i			
actice properties, we have fell	vesilualeu ine	issue of the interfac	e of SiO2/Si(111)	ising the current	state of the art matheds of suit			
CAIGE GIOWIII. THE SI(ZD) COTE IS	ever lias a rela	suveiv large chemica	al sniff which is not	rly ideal for ideas	ificing the interfere and the state			
with one of the bulk of(2p) billi	uma enerav ra)r 5)(111) is ~99.3 e\	V and the bulk Si/2	n) ovide value for	film thickness - 20 Å C:00 :-			
100.7 ev. [1] The billiand eller	gies of the thr	ee interrace-sniffed i	Deaks are intermed	liate hetween the	se values. These have here			
assigned by Himpsel et al. [2] as the intermediate oxidation states of Si atoms usually labeled Si1+, Si2+ and Si3+ with the bulk Si peak labeled Si0 and the bulk oxide peak labeled Si4+. BeamlineU4A has just completed the first phase of a major upgrade. As part								
of the DOE Facilities Initiative w	ve are adding	spherical gratings a	O4A has just comp	pleted the first pha	ase of a major upgrade. As part			
and fixed slits to acheive a sphe	rical toroidal o	oprierical gratings at	tor (STGM) More	detailed informat	e, replacing the toroidal gratings ion has become a vital concern in			
core-electron photoennission stu	iules iliai wele	e started a few vears	ago. For example	the reconstructi	on of Si curfaces recults in passive			
resolved surface-atom core-elec	tron binding-e	energy shifts that are	not readily determ	ined without relia	able information about the			
instrumental width.			-					
14. SUBJECT TERMS					15. NUMBER OF PAGES			
	18							
X-Ray Photoemission, Ultra								
		16. PRICE CODE						
17. SECURITY CLASSIFICATION	18. SECURIT	Y CLASSIFICATION	19. SECURITY CI	ASSIFICATION	20. LIMITATION OF ABSTRACT			
OR REPORT	ON THIS		OF ABSTRAC	Γ	I ABSTRACT			
UNCLASSIFIED NSN 7540-01-280-5500	J UNC	CLASSIFIED	INCLAS	SSIFIED	UL OLL			
					Standard Form 298 (Rev.2-89)			

20000707 026

Prescribed by ANSI Std. 239-18 298-102

1998 ARO FINAL PROGRESS REPORT

Rutgers University and North Carolina State University

I. General Goals and Objectives.

At Brookhaven National Lab the Rutgers University et al. U4A PRT is centered around the use of photoemission spectroscopy to study electronic structure in solids and on surfaces. Two fully equipped surface analysis chambers are used in tandem on the beamline, and the PRT is equipped to make full use of the available synchrotron radiation. The PRT is comprised of groups from Boston University, North Carolina State University/Rutgers University, and the NSLS. Each group has its own independent scientific goals, and the motivation for PRT itself is the use of common synchrotron radiation based spectroscopic techniques. The goal of the Boston University group (Kevin Smith's group) is the study of bulk and surface electronic structure in low dimensional oxide conductors, organic superconductors, and wide band gap semiconductors. The goal of the group from NCSU-Rutgers (Jack Rowe's group, in collaboration with Ted Madey) is to use core level photoemission to study inerfaces and surfaces of electronic materials and metallic systems. There is also an effort to upgrade this beamline to a Spherical Grating Monochromator (SGM) which is being performed in collaboration with Steve Hulbert of NSLS.

II. Significant Scientific Results.

Rutgers University - North Carolina State University -

The detailed atomic SiO_2 /Si interface structure and interface state density for ultrathin SiO_2 (~10-40 Å) remains a somewhat controversial topic with some arguing for atomically abrupt (i.e. ~ 1 monolayer, ML) interfaces while others propose a larger transition region of ~10 Å thickness. Previous soft x-ray photoelectron spectroscopy (SXPS)

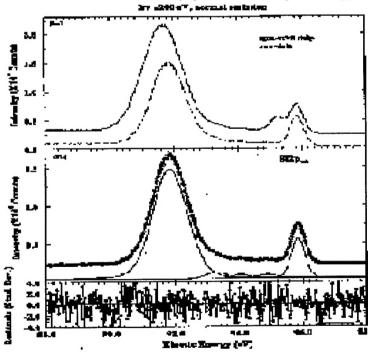


Figure 1 SXPS data for Si(100) with a 15 Å SiO₂ layer showing raw data, spin-orbit stripped data, and a non-linear least-squares fit to the stripped data. The lower panel shows the residuals of the fit.

measurements at NSLS by Himpsel et al. gave an interface width of 3-5 Å (~2 ML) for both (111) and (100) interfaces. A crucial issue that continues to inhibit understanding of spectroscopic measurements is sample preparation at the device-grade level of processing such that interface details can be usefully compared to other measurements. We have used high

Page 2 - 1998 ARO Final Progress Report Rutgers University

resolution SXPS at NSLS to study ultrathin gate oxides grown on Si(111) that achieve these device-quality interface conditions. Since gate oxides used in current devices have continued to decrease in thickness with corresponding improvements in oxide growth, processing and device properties, we have reinvestigated the issue of the interface of SiO₂/Si(111) using the current state-of-the-art methods of gate oxide growth. The Si(2p) core level (see Fig.1) has a relatively large chemical shift which is nearly ideal for identifying the interface oxide states with SXPS. The bulk Si(2p) binding energy for Si(111) is ~99.3 eV and the bulk Si(2p) oxide value for film thickness ~ 30 Å SiO₂ is ~103.7 eV. [1] The binding energies of the three interface-shifted peaks are intermediate between these values. These have been assigned by Himpsel *et al.* [2] as the intermediate oxidation states of Si atoms usually labeled Si¹⁺, Si²⁺ and Si³⁺ with the bulk Si peak labeled Si⁰ and the bulk oxide peak labeled Si⁴⁺.

Results for surface state density measurements for various samples are shown in Table I. The three columns are for the three interfaces state peaks and are measured in fractional monolayers (ML). The total interface state density is shown in the last column and varies from ~ 1.5 to ~ 2 ML.

Table I. Fitting results summary for interface state densities $(1 \text{ ML} \sim 7.8 \times 10^{14} \text{ cm}^{-2} \text{ on Si}(111)).$

sample	Θ_1 (ML)	Θ_2 (ML)	Θ_3 (ML)	ΣΘ (ML)
SiO ₂				
as grown (300 °C)	0.87	0.59	0.38	1.84
700 °C	0.92	0.26	0.42	1.60
800 °C	0.82	0.23	0.58	1.63
900 °C	0.79	0.30	0.46	1.56
SiO_2 / N_2^*				
as grown (300 °C)	0.91	0.48	0.62	2.01
700 °C	0.80	0.41	0.58	1.79
800 °C	0.70	0.42	0.60	1.73
900 °C	0.70	0.42	0.60	1.72

In related experiments on bimetallic catylyst systems, high resolution soft X-ray photoelectron spectroscopy (XPS) is used to study model bimetallic interfaces, i.e., Pt, Pd, Au and Ir films on W (211). The metal film growth and evolution during annealing has been investigated for coverages ranging from 0 to 10 monolayers. It is found that the films grow in a layer-by-layer mode at 300 K. As a function of the overlayer film thickness, several different overlayer $4f_{7/2}$ photoemission peaks are observed, as shown in Fig. 2 for Pt on W(211),

Page 3 - 1998 ARO Final Progress Report Rutgers University

corresponding to a single monolayer, two interface layer atoms, bulk atoms and surface atoms.

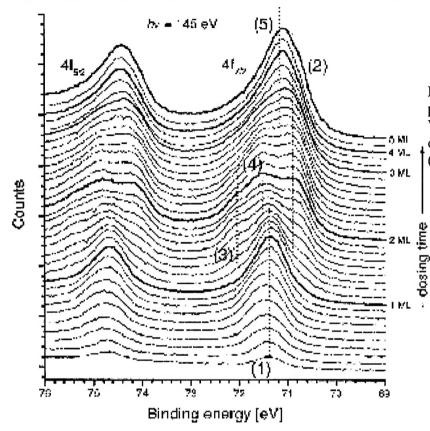


Figure 2 Pt $4f_{7/2}$ and $4f_{5/2}$ SXPS peaks for various coverages on W(211) surfaces. Note that five different Pt peaks are found. Peak (5) is due to bulk Pt.

A single monolayer of each overlayer metal is stable against thermal rearrangement. In contrast, when multilayer films of Pt, Pd, Ir are annealed above 600 K substrate W atoms diffuse into the overlayer to form an alloy - a distinct new W $4f_{7/2}$ peak appears. This peak is shifted ~ 1 eV for Pt and Pd, and about 0.5 eV for Ir, toward higher binding energy as compared with the substrate W peak. In the case of an Au film, no alloying is found. The evolution of the bimetallic systems as a function of coverage and annealing temperature is diagnosed by analysis of intensities and angular dependencies of the substrate and overlayer $4f_{7/2}$ features. Electronic properties are discussed on the basis of the core level peak shifts and shapes and valence band spectra. The data provide detailed information on adhesion, segregation and alloying early d - late d transition metals system. Unusual enhancement of acetylene cyclization reaction over Pd/W(211) model catalyst is found to be related to the formation of a W-Pd surface alloy.

III. Instrumentation and Other Beamline Upgrades.

BeamlineU4A has just completed the first phase of a major upgrade. As part of the DOE Facilities Initiative, we are adding spherical gratings and a movable exit slit to the beamline, replacing the toroidal gratings and fixed slits to acheive a spherical toroidal grating monochromator (STGM). A few years ago, modest efforts were made to determine the inherent resolution of the three toriodal gratings that were installed in the late 1980's. In an earlier study the total widths of the Fermi cut-off in the conduction band of Cu(001) were reported to be 230, 140, and 90 meV, for the high, medium, and low energy gratings, G1, G2, and G3 respectively, but no attempt was made to separate the contributions of the TGM itself.

More detailed information has become a vital concern in core-electron photoemission studies that were started a few years ago. For example, the reconstruction of Si surfaces results in poorly resolved surface-atom core-electron binding-energy shifts that are not readily determined without reliable information about the instrumental width. Accurately known core-level line shapes are also required to estimate the disorder broadening associated with adsorbate-covered surfaces. The study of phonon excitations, that accompany the photoemission process similarly requires accurate knowledge of the instrumental contribution to the line width. For bimetallic-overlayer systems, high resolution measurements of surface core level shifts are needed to identify the electronic properties responsible for metal-induced faceting of bcc(111) substrates.

Our objective of the new STGM configuration is to achieve high resolution and high photon throughput. This will be accomplished using the spherical grating monochromator (SGM) design pioneered by the AT&T Bell Labs "Dragon" beamline U4B. This design has now become standard for beamlines in the soft x-ray range. It is less frequently used in the mid-range of 10-200 eV photon energy. However, recent experience on U7 at higher photon energies (200-1000 eV) suggests that the conversion from the modest resolution Toroidal Grating Monochromator (TGM) to the SGM design can be accomplished with a reuse of most beamline components including mirror chambers, grating chamber, scanning mechanism, and slit assemblies. What cannot be reused are the existing gratings (three of them) and one of the two refocusing mirrors. All five of the chambers which are in the beamline (and house these optical elements) were reused in the newly upgraded beamline. In addition, the current exit slit assembly was rebuilt into a movable slit assemblycomplete with granite block table, constructed at NCSU, using drawings from NSLS. The total cost of the upgrade funded is \$120 K. All other required items have currently been replaced and commissioning of the new STGM configuration is now in progress. The upgrade collaboration was lead by Dr. Steve Hulbert of the NSLS and Prof. Jack Rowe of NCSU. A computer upgrade by the NCSU-Rutgers group has also recently been completed. This computer uses Unix based software written by Gunther Wertheim who is acting as a software consultant to the PRT for monochromator control programs

Rutgers University and *North Carolina State University* **Publications** - Copies of papers 3 and 4 are attached.

- "W(111)-based Bimetallic Systems: Core Level Photoelectron Spectroscopy Studies"
 H.-S. Tao, T. E. Madey and J. E. Rowe, Surface Science, 407, L640-L646 (1998).
- "Ultrathin Metal Films on W(221): Structure, Electronic Properties, and Reactivity"
 J. J. Kolodziej, K. Pelhos, I. M. Abdelrehim, J. Keister, J. E. Rowe, and T. E. Madey, Progress in Surface Science, 59, 117-134 (1998).
- "Structure of Ultrathin SiO₂/Si(111) Interfaces Studied by Photoelectron Spectroscopy"

 J.W. Keister, J. E. Rowe, J.J. Kolodziej, H. Niimi, H.-S. Tao, T. E. Madey, and G. Lucovsky, Journal of Vacuum Science and Technology, A 17, 1250-1257 (1999).
- 4 "Band Offsets for Ultrathin SiO₂ and Si₃N₄ films on Si(111) and Si(100) from Photoemission Spectroscopy" J.W. Keister, J. E. Rowe, J.J. Kolodziej, H. Niimi, T. E. Madey, and G. Lucovsky, Journal of Vacuum Science and Technology, B 17, 1831-1835 (1999).
- "Photoelectron Spectroscopy Studies of Adhesion, Segregation and Alloying for Transition Metal-W(211) Bimetallic Systems" J.J. Kolodziej, T. E. Madey, J.W. Keister, and J. E. Rowe, Physical Review B (submitted).